



1 for 2616

1 hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: August 24, 2007      Signature: \_\_\_\_\_  
(James P. Zeller)

Docket No.: 30952/42261  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Weishi Li et al.

Application No.: 10/590,121

Confirmation No.: 2107

Filed: August 18, 2006

Art Unit: 2616

For: Semiconductor Device and Method for Forming  
Pattern in the Same

Examiner: Not Yet Assigned

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: August 24, 2007

Respectfully submitted,

By \_\_\_\_\_

James P. Zeller

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